Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	4	semiconductor and (metal adj monoxide)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/26 17:50
L2	129750	semiconductor and (gate adj electrode)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/26 17:50
L3	21503	2 and ((metal or conductive) adj oxide)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/26 17:51
L4	1381	3 and (work adj function)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/26 17:51
L5	43	4 and monoxide	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2005/10/26 17:51